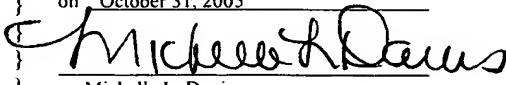


PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-----------------------------------|--|---|
| <i>Group</i> | | <u>Certificate Under 37 C.F.R. 1.10</u> |
| <i>Art Unit:</i> | Unknown | "EXPRESS MAIL" MAILING LABEL NUMBER <u>EL905878333US</u> DATE OF DEPOSIT <u>October 31, 2005</u> I HEREBY CERTIFY THAT THIS PAPER OR FEE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE "EXPRESS MAIL" POST OFFICE TO ADDRESSEE" SERVICE UN- DER 37 C.F.R. 1.10 ON THE DATE INDICATED ABOVE AND IS ADDRESSED TO THE ASSIS- TANT COMMISSIONER FOR PATENTS WAS- HINGTON, DC 20231. on: <u>October 31, 2005</u>  <u>Michelle L. Davis</u> |
| <i>Attorney</i> | | |
| <i>Docket No.:</i> | RAC0082 | |
| <i>Applicant:</i> | Alexander HAUSER et al. | |
| <i>Invention:</i> | METHOD FOR TEXTURING SURFACES OF SILICON WAFERS | |
| <i>Serial No.:</i> | Unknown | Filed: <u>Herewith</u> |
| <i>International Serial No.:</i> | PCT/DE2004/000835 | |
| <i>International Filing Date:</i> | 22 April 2004 | |
| <i>Examiner:</i> | Unknown | |

PRELIMINARY AMENDMENT

Box: PCT
 Attn: DO/EO/US
 Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

Prior to the examination of the above-identified application, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.